

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. SHIRAYONE, et al.
Application No.: 10/791,856
Filed: MARCH 4, 2004
For: METHOD FOR PROCESSING PLASMA PROCESSING
APPARATUS
Group AU: 1792
Examiner: Stephen K. Ko
Confirm. No.: 5252

AMENDMENT

Mail Stop: AMEND - FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

May 22, 2009

SIR:

In response to the Office Action mailed January 23, 2009, the period for response having been extended for one (1) month by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.